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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re application of: Shrinivasan et al.

Attorney Docket No.:  
NOVLP029/NVLS-000495

OFFICIAL

Application No.: 10/067,520

Examiner: Kornakov, Michael

Filed: February 5, 2002

Group: 1746

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CENTRAL FAX CENTERTitle: APPARATUS AND METHODS FOR  
PROCESSING SEMICONDUCTOR  
SUBSTRATES USING SUPERCRITICAL  
FLUIDS

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**CERTIFICATE OF TRANSMISSION**

I hereby certify that this correspondence is being transmitted via facsimile to the U.S. Patent and Trademark Office, Attention: Examiner Michael Kornakov at facsimile telephone number (703) 872-9306 on June 23, 2004.

Printed Name: Natalie Morgan

Signed: **AMENDMENT A**Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated March 25, 2004, please amend the above-identified patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which being on page 2 of this paper.

**Remarks/Arguments** begin on page 12 of this paper.